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PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of: )

Tzeng )

Serial No: 09/501,114 )

Filed: February 10, 2000 )

For: Method of Plasma Enhanced )  
Chemical Vapor Deposition )  
of Diamond )

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

Applicant hereby voluntarily discloses the information listed on the attached Form PTO-1449 to the Commissioner of Patents and Trademarks. A copy of U.S. Patent No. 5,945,152 is enclosed herewith.

This disclosure supplements a May 10, 2000, Information Disclosure Statement. Copies of the reference listed on the attached Form PTO-1449 are being submitted at this seemingly late date because they were only recently brought to our attention; a certification, as specified in paragraph (e) of 37 CFR 1.97, is enclosed herewith.

Applicant further reserves the right to establish the patentability of the claimed invention over any of the listed information should they be applied as references, and/or to prove that some of the cited information may not be prior art, and/or to prove that some of the cited information may not be enabling for the teachings they purport to offer. This statement further should not be construed as the representation that an exhaustive search has been made, or that the information cited herewith is material, or that there does not exist information more material to the examination of the present Application. The Examiner is specifically requested not to rely solely

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on the information submitted herein. On the contrary, the Examiner is requested to conduct an independent and thorough review of the information, and to form independent opinions as to their significance.

It is respectfully requested that the Examiner initial and return a copy of the enclosed PTO-1449 and to indicate in the official file wrapper of the above-identified patent application that each item of the cited information has been considered.

Respectfully submitted,

3/21/02  
Date

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Thomas B. McGurk  
Reg. No. 44,920

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Docket No.: A029 1080



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37 CFR 1.97(e) CERTIFICATION

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

This certification is being submitted, in accordance with 37 CFR 1.97(d), with the Supplemental Information Disclosure Statement enclosed herewith. No item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in §1.56(c) more than three months prior to the filing of the information disclosure statement.

The fee set forth in §1.17(p) is included herewith as a check in the amount of \$180.00.

Respectfully submitted,

3/21/02  
Date

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Docket No.: A029 1080



\$ 1762

# CERTIFICATE OF MAILING

I hereby certify that this correspondence is being mailed in an envelope by First Class mail to:

Assistant Commissioner for Patents  
Washington, D.C. 20231

on 3/25/02

Diana Ogles  
(Typed or printed name of person mailing correspondence)

[Signature]  
(Signature of person mailing correspondence)

Serial Number: 09/501,114      Fling Date: February 10, 2000  
Title: METHOD OF PLASMA ENHANCED CHEMICAL VAPOR  
DEPOSITION OF DIAMOND  
Our Reference Number: A029 1080

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Supplemental Information Disclosure Statement  
37 CFR 1.97(e) Certification  
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